

Electronic Patent Application Fee Transmittal

Application Number:	10812354			
Filing Date:	30-Mar-2004			
Title of Invention:	Method of improving the wafer to wafer uniformity and defectivity of a deposited dielectric film			
First Named Inventor/Applicant Name:	Noriaki Fukuiage			
Filer:	James Klekotka			
Attorney Docket Number:	071469-0308969 (FKL-020)			

Filed as Large Entity

Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
-------------	----------	----------	--------	----------------------

Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Extension - 1 month with \$0 paid	1251	1	130	130
-----------------------------------	------	---	-----	-----

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				130